

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/770,090	SEMEIA, ROBERTO		
Examiner	Art Unit		
John Rivell	3753		

SEARCHED						
Class	Subclass	Date	Examiner			
137	512.15 852 854	8/14/2006	8			
128	200.29	8/14/2006				
128	204.26	8/14/2006	VXX			
128	204.27	8/14/2006	R			
128	205.24	8/14/2006	1/2			
128	207.12	8/14/2006	11/2			

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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Interference Search History Printout		4/18/2007	K		
			IV \		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
		DATE	EXMR	
None		8/14/2006	R	
			<i>)</i>	